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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 8585**  
Takashi OHSAKO et al. : Attorney Docket No. 2003\_1364A  
Serial No. 10/677,221 : Group Art Unit 2823  
Filed October 3, 2003 : Examiner Joannie Garcia  
  
METHOD OF MANUFACTURING  
SEMICONDUCTOR ELEMENT : **Mail Stop: Amendment**

**PATENT OFFICE FEE TRANSMITTAL FORM**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Attached hereto is a check in the amount of \$120.00 to cover Patent Office fees relating to filing the following attached papers:

Petition for Extension of Time ..... \$120.00

A duplicate copy of this paper is being submitted for use in the Accounting Division, Office of Finance.

*The Commissioner is authorized to charge any deficiency or to credit any overpayment associated with this communication to Deposit Account No. 23-0975, with the EXCEPTION of deficiencies in fees for multiple dependent claims in new applications.*

Respectfully submitted,

Takashi OHSAKO et al.

By

W. Douglas Hahm  
Registration No. 44,142  
Attorney for Applicants

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WENDEROTH, LIND & PONACK, L.L.P.  
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July 7, 2008

[Check No. 86554]  
2003\_1364A



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**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Petition hereby is made for a one month extension of time to respond to the communication of  
March 4, 2008.

The fee of \$120.00 is

(X) submitted herewith.

( ) to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is  
enclosed.

Respectfully submitted,

Takashi OHSAKO et al.

By

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July 7, 2008

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THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975